

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Hirohiko Nishiki

Docket No.

SLA0454

Serial No
10/021,342Filing Date
December 12, 2001Examiner
T. R. ChowdhuryGroup Art Unit
2871

Invention: System and Method for Forming Ozone Resistant IC and LCD Structures (as amended)

TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	15 -	29 =	0	x \$18.00	\$00.00
INDEP. CLAIMS	6 -	7 =	0	x \$84.00	\$0.00
Multiple Dependent Claims (check if applicable)					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$00.00

 No additional fee is required. Please charge Deposit Account No. _____ in the amount of

A duplicate copy of this sheet is enclosed.

 A check in the amount of _____ to cover the filing fee is enclosed. The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.

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 Any additional fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 C.F.R. 1.17.

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Dated: JULY 8, 2003 TECHNOLOGY CENTER 2800

David C. Ripma, Reg. No. 27,672

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9318 on July 8, 2003.

David C. Ripma, Reg. No. 27,672

Note: Each paper must have its own certificate or transmission, or this certificate must identify each submitted paper. The papers submitted include:

 This Amendment Transmittal Letter (Duplicate Attached)

2 page(s)

 Response under 37 CFR § 1.111

12 page(s)

 Attachments

page(s)

 Petition for Extension of Time under 37 C.F.R. § 1.136 (Duplicate Attached)

page

Total pages, including this Transmittal: 14

2/6

#6/A 8B

7/11/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Inventors: Hirohiko Nishiki)
Serial No.: 10/021,342) ATTORNEY FILE NO.
Filed: December 12, 2001) SLA 454
Title: SYSTEM AND METHOD FOR)
FORMING OZONE)
RESISTANT IC AND LCD)
STRUCTURES (as amended))

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Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND REQUEST FOR RECONSIDERATION

In response to an Office Action filed June 11, 2003, please
amend and reconsider as follows.